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(71) Applicant (for all designated States except US): MI-CRONIC LASER SYSTEMS AB [SE/SE]; IPR & Legal Dep, Nytorpsvägen 9, S-183 03 Täby (SE).

(72) Inventor; and

(75) Inventor/Applicant (for US only): SANDSTRÖM, Torbjörn [SE/SE]; Banvägen 56, S-435 43 Pixbo (SE).

(74) Agent: NORDKVIST, Johan; Micronic Laser Systems AB, IPR & Legal Dep, Nytorpsvägen 9, S-183 03 Täby (SE).

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(54) Title: METHOD AND APPARATUS FOR PRINTING PATTERNS WITH IMPROVED CD UNIFORMITY

(57) Abstract: An aspect of the present invention includes a method to pattern a workpiece with improved CD uniformity using a partially coherent electromagnetic radiation source. Said method including the actions of: determining, for a plurality of layers in said workpiece, CD uniformity as a function of a number of exposure flashes, determining, for the plurality of layers in said workpiece, the cost of patterning as a function of the number of exposure flashes, and selecting the number of exposure flashes on a layer by layer basis, which gives a predetermined CD uniformity corresponding to a preferred cost. Other aspects of the present invention are reflected in the detailed description, figures and claims.

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